

## EMVA 2026 Young Professional Award

### - Call for Application -

The **EMVA Young Professional Award** is an annual award endowed with **1500 Euros** to honor the outstanding and innovative work of a student or a young professional in the field of machine vision or image processing.

It is the goal of the European Machine Vision Association EMVA to support further innovation in our industry, to contribute to the important aspect of dedicated machine vision education, and to provide a bridge between research and industry.

The winner of the award will be announced at the flagship **EMVA Business Conference 2026** taking place June 18<sup>th</sup> – 20<sup>th</sup> in Stockholm, Sweden, and will have the opportunity to present the awarded work to the machine vision industry leaders from Europe and abroad. The presentation will then be published by the international machine vision press.



In addition to the honor of the **EMVA Young Professional Award** endowed with 1500 Euros and the publicity for the research work is a free conference pass for the EMVA Business Conference as well as the coverage of all travel cost to Stockholm and a free pass for the *2026 European Machine Vision Forum*.

With our award, we would like to specifically encourage students and young scientists to focus on challenges in the field of machine vision and to apply latest research results and findings in computer vision to the practical needs of our industry.

Previous winners of the award have continued to achieve great success in the vision industry and benefited from the high profile the award brings.

The criteria of the works to be presented for the EMVA Young Professional Award are:

- (1) Outstanding or innovative work in the field of vision technology.  
Industrial relevance and collaboration with a company during the work is required.  
The targeted industry is free of choice.

(2) The work (master thesis or PHD thesis or equivalent level research) must have been undertaken within the last 18 months at, or in collaboration with, an European institution. Meanwhile the student may have entered the professional field.

To apply please submit the following materials to the EMVA President, Dr Chris Yates, at [ypa@emva.org](mailto:ypa@emva.org) latest until April 5<sup>th</sup>, 2026:

- A two-page abstract summarizing the innovation and the intended commercial benefit
- A one-page CV
- A copy of the master thesis or PhD thesis. If not yet finished or under publication restrictions, please provide at least one accepted publication

Supportive letters of research supervisors and/or any collaborating company are welcomed but not mandatory.

Among the papers the EMVA Board of Directors, representing the European Machine Vision Industry, will select the winner of the award.

Dr. Chris Yates  
EMVA President

Thomas Lübkemeier  
EMVA General Secretary